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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/791,190	03/02/2004	Frank L. Hall	4718.3US (00-0316.03/US)	1971
24247 75	590 03/15/2006		EXAM	NER
TRASK BRIT	T	•	HEINRICH, SAMUEL M	
P.O. BOX 2550 SALT LAKE CITY, UT 84110			ART UNIT	PAPER NUMBER
	,		1725	

DATE MAILED: 03/15/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
Office Action Summary	10/791,190 Examiner	HALL, FRANK L.			
• • • • • • • • • • • • • • • • • • •		Art Unit			
The MAILING DATE of this communication	Samuel M. Heinrich appears on the cover sheet with	th the correspondence address			
Period for Reply	·				
A SHORTENED STATUTORY PERIOD FOR REI WHICHEVER IS LONGER, FROM THE MAILING  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the may be earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNIC 1.136(a). In no event, however, may a re- tod will apply and will expire SIX (6) MON' tute, cause the application to become AB	CATION.  pply be timely filed  THS from the mailing date of this communication.  ANDONED (35 U.S.C. § 133).			
Status	•				
1) Responsive to communication(s) filed on 03	3 January 2006.				
2a) ☐ This action is <b>FINAL</b> . 2b) ☐ This action is non-final.  3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
Disposition of Claims	,				
4) Claim(s) 1-21 is/are pending in the applicati	on.	•			
4a) Of the above claim(s) is/are withd	rawn from consideration.	•			
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>1-21</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and	d/or election requirement.	·			
Application Papers					
9) The specification is objected to by the Exam	iner.				
10)⊠ The drawing(s) filed on <u>02 March 2004</u> is/are		ected to by the Examiner.			
Applicant may not request that any objection to t					
Replacement drawing sheet(s) including the corr	ection is required if the drawing(	s) is objected to. See 37 CFR 1.121(d).			
11)☐ The oath or declaration is objected to by the	Examiner. Note the attached	Office Action or form PTO-152.			
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for forei	an priority under 35 LLS C S	110(a) (d) or (f)			
a) ☐ All b) ☐ Some * c) ☐ None of:	gir priority under 55 0.5.6. g	119(a)-(d) or (i).			
1. ☐ Certified copies of the priority docume	ents have been received				
2. Certified copies of the priority docume		oplication No.			
3. ☐ Copies of the certified copies of the p					
application from the International Bure					
* See the attached detailed Office action for a l	ist of the certified copies not r	received.			
	, .				
-					
Attachment(s)		•			
	4) 🔲 Interview Si	ummary (PTO-413)			
2) D Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)	)/Mail Date			
<ol> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date</li> </ol>	08) 5) ☐ Notice of Int 6) ☐ Other:	formal Patent Application (PTO-152) .			
S. Patent and Trademark Office		<u> </u>			

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### **DETAILED ACTION**

# Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 1-21 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. Apparatus or system claims 1-21 are described using method language limitations which may not clearly define the claimed structure.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over USPN 4,752,668 to Rosenfield in view of USPN 5,442,416 to Tateyama.

Rosenfield teaches the process and system for removing excess material from a semiconductor wafer employing an excimer laser. The wafer has been previously treated by treating a semiconductor with a resist, exposed, developed and selectively removed for the purposes of patterning various areas of the wafer. But such a manufacturing process leaves some of the resist and contaminants on the wafer. Rosenfield recognizes the need to remove the excess resist and contaminants and provides a method and system for their removal with a laser.

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Tateyama, while describing prior art, describes (Fig. 1) the method and apparatus for providing a substrate (wafer), subjecting to a preheating step (4) to remove moisture, cooled, conveyed to a coating unit where a photo-resist is evenly coated on the surface of the wafer, and the "photo-resist-coated wafer W is sent to a heating unit 8" where "the photo-resist solution on the wafer is converted into a stable film". This is the "baking" step in applicant's claims. Afterwards, the pattern is developed and excess resist material is removed.

The difference between the claimed invention and the combined teachings of Rosenfield and Tateyama is that Tateyama teaches the "prior art" recognized in Rosenfield, and Rosenfield provides the cleaning steps with a laser after the semiconductor wafer has been patterned, after a substrate (wafer) has been treated with an initial preheating, application of a resist layer on the substrate (wafer), and a baking step, according to the method of Tateyama. Therefore, in view of the difference between the subject matter as a whole sought to be patented and the totality of the teachings of prior art, as established above, it would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains, to follow the teachings of Rosenfield and provide a step and apparatus for the removal of contaminants from a substrate with a laser after the substrate has been preheated (to remove moisture), coated with a resist layer and heated (baked) and patterned in the method and apparatus taught in Tateyama.

Claim Rejections - 35 USC § 102

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The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.
- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-21 are rejected under 35 U.S.C. 102(b) as being anticipated by JP403155488A. The English Abstract describes a combination of a mold and a laser. The intended use of the apparatus with a particular work piece or with method limitations does not impart patentability to the apparatus claims.

Claims 1-21 are rejected under 35 U.S.C. 102(b) as being anticipated by JP05144093A. The English Abstract describes a combination of a mould and a laser. The instant claimed intended use with automolding does not impart patentability to the apparatus claims.

Claims 1-21 are rejected under 35 U.S.C. 102(b) as being anticipated by JP408167769A. The English Abstract describes a combination of a molded part and a laser. The instant claimed intended use with automolding or with a particular substrate or other method limitations does not impart patentability to the apparatus claims.

Claims 1-21 are rejected under 35 U.S.C. 102(b) as being anticipated by JP11006073A. Figure 3 shows a combination of a mould and a laser. The laser is used to remove resist. The instant claimed intended use does not impart patentability to the apparatus claims.

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Claims 1-21 are rejected under 35 U.S.C. 102(a) as being anticipated by USPN 6,866,910 to Kamezaki et al. Kamezaki et al describe Figure 9 as comprising steps of exposing resist to laser irradiation and subsequent molding. The instant claimed automolding does not impart patentability to the apparatus claims.

Claims 2, 5, 8, 11, 14, 17, and 20 are rejected under 35 U.S.C. 103(a) as obvious over JP403155488A or JP05144093A or JP408167769A or JP11006073A or USPN 6,866,910 in view of USPN 4,904,498 to Wu. Wu describes (Abstract) well known excimer laser for removal of resist and the use of an excimer laser in any of the base references would have been obvious at the time applicant's invention was made to a person having ordinary skill in the art because the laser is efficient for resist removal.

# Response to Arguments

In response to applicant's argument that the use of the apparatus in Rosenfield et al and Tateyama et al is not the same as applicant's use, a recitation of the intended use of the claimed invention must result in a structural difference between the claimed invention and the prior art in order to patentably distinguish the claimed invention from the prior art. If the prior art structure is capable of performing the intended use, then it meets the claim.

Applicant's arguments with respect to claims 1-21 have been considered but are moot in view of the new ground(s) of rejection.

### Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP

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§ 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel M. Heinrich whose telephone number is 571-272-1175. The examiner can normally be reached on M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, P. Ryan can be reached on 571-272-1292. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Samuel M Heinrich Primary Examiner Art Unit 1725